OLIFF & BERRIDGE, PLC

TTORNEYS AT LAW

plemental Application Data Sheet

Application Information

Application Type::

Regular

Subject Matter::

Utility

CD-ROM or CD-R:

None

Title::

METHOD OF MANUFACTURING OXIDE THIN

FILM, METHOD OF MANUFACTURING

FERROELECTRIC THIN FILM, FERROELECTRIC

THIN FILM, FERROELECTRIC MEMORY

DEVICE, AND FERROELECTRIC

PIEZOELECTRIC DEVICE

Attorney Docket Number::

117926

Total Drawing Sheets::

14

Small Entity::

No

Applicant Information

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Takeshi

Family Name::

KIJIMA

City of Residence::

Matsumoto-shi

State or Province of Residence::

Nagano-ken

Country of Residence::

Japan

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Eiji

Family Name::

NATORI

City of Residence::

Chino-shi

State or Province of Residence::

Nagano-ken

Country of Residence::

Japan

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priorit	y Information		
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-349818	12/02/2002	Yes
Assignee Infor	mation		
Assignee Name:: Street of mailing address::		SEIKO EPSON CORPORATION	
		4-1, Nishi-shinjuku 2-chome, Shinjuku-ku	
City of mailing address:: Country of mailing address::		Tokyo Japan	
Country of Itiali	ing address	очран	

6/28/04